

**AMENDMENTS TO THE SPECIFICATION**

**On page 12, please delete the first paragraph and replace it with the following one:**

| ~~Fig~~Figs. 22A and 2B ~~is~~are ~~a view~~views showing the characteristic of film growth by plasma CVD according to the invention;

**On page 13, please delete the third paragraph and replace it with the following one:**

| ~~Fig~~Figs. 16~~16A and 16B~~ ~~is~~are a section ~~view~~views of a multilayer film structure disclosed in JP-A-8-307008; and